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CONFIRMATION NO. 7221

SERIAL NUMBER 10/039,196	FILING DATE 01/02/2002 RULE	CLASS 417 428	GROUP ART UNIT 1765 1772	ATTORNEY DOCKET NO. MEMC 00-1400 (2806.1)
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APPLICANTS

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** CONTINUING DATA *****

THIS APPLN CLAIMS BENEFIT OF 60/259,362 01/02/2001

yes QR

** FOREIGN APPLICATIONS *****

none QR

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/28/2002

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY UNITED KINGDOM	SHEETS DRAWING 17	TOTAL CLAIMS 59	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature Initials				

ADDRESS

000321

TITLE

Process for preparing single crystal silicon having improved gate oxide integrity

FILING FEE RECEIVED 2356	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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